



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Masahiro HATAKEYAMA et al.**

Group Art Unit: **2881**

Serial Number: **10/030,087**

Examiner: **Phillip A. Johnston**

Filed: **January 14, 2002**

Confirmation No.: **4284**

For: **BEAM SOURCE**

Customer No. **38834**

Docket No. 020018

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 30, 2005

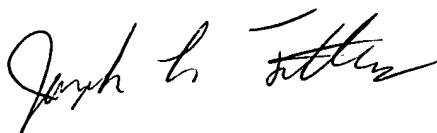
Sir:

Applicants appreciate the Examiner's allowance of the above-identified application, and applicants also note the Reasons for Allowance dated April 26, 2005.

Applicants agree that the claims should be allowed, including claims 1, 5, and 11. Applicants recognize that one reading the Reasons for Allowance *might* infer that claim 1 specifies that applicants' beam source is configured such that "charge exchange takes place in said beam emitting holes formed in the downstream electrode, resulting in an emission of a neutral particle beam." However, claim 1 (and claims 5 and 11 depending therefrom) does not recite the quoted text. Of course, the claim is allowable anyway for reasons already made of record by applicants.

In the event that this paper is not timely filed, applicants petition for an appropriate extension of time. The fees for such an extension, or any other fees which may be due, may be charged to Deposit Account No. 50-2866.

Respectfully submitted,
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

A handwritten signature in cursive script, appearing to read "Joseph L. Felber".

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